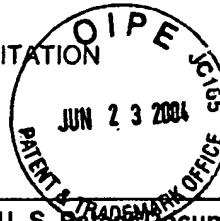


INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)
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(MKS-134)Application Number
10/814,973

Applicant A. Shajii et al.

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Group Art Unit

U. S. Patent Documents

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
C	A	4,796,854	01/10/89	Ewing	251	129.07	05/18/87

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

C	B	© 2000 MKS Instruments, Inc., "Pressure-Based Mass-Flo® Controller For Ion Implant Applications Type 1640," Bulletin 1640 – 4/00.
C	C	© 2000 MKS Instruments, Inc., "Metal-Sealed Mass-Flo® Controller Type 1479A," Bulletin 1479A-5/00.

EXAMINER

DATE CONSIDERED

6/21/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.